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October 11, 2005

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on October 11, 2005.

Gayle W. Chaney

Date of Signature:

10/11/05

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Re: U.S. Patent Application Serial No. 10/801,781 for
PROCESS FOR PRODUCING AN ETCHING MASK ON A
MICROSTRUCTURE, IN PARTICULAR A SEMICONDUCTOR
STRUCTURE WITH TRENCH CAPACITORS, AND
CORRESPONDING USE OF THE ETCHING MASK
Our Ref. No. 1406/189

Sir:

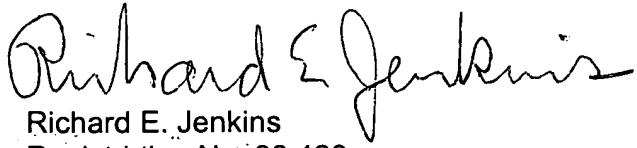
Please find enclosed in connection with the subject U.S. patent application the following documents:

1. An Amendment A with Replacement Abstract; and
2. A return-receipt postcard to be returned to us with the U.S. Patent and Trademark Office filing stamp thereon.

The Commissioner is hereby authorized to charge any fees associated with the filing of this correspondence to Deposit Account Number 50-0426.

Respectfully submitted,

JENKINS, WILSON & TAYLOR, P.A.


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REJ/gwc

Enclosures

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